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## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Group Art Unit: 2811  
Examiner Hung K. Vu

In Re PATENT APPLICATION Of:

Applicants:	Junichi HIKITA et al.	)	
Serial No:	10/797,018	)	<b>INFORMATION</b>
Filed:	March 11, 2004	)	<b>DISCLOSURE</b>
For:	SEMICONDUCTOR CHIP AND PRODUCTION THEREOF, AND SEMICONDUCTOR DEVICE ....	)	<b>STATEMENT</b>
Docket No.:	AI 257D1	)	

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

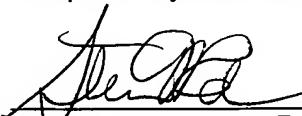
Sir:

This is an Information Disclosure Statement submitted in compliance with the timing requirements of 37 C.F.R. §1.97(c)(2), i.e., after a first Office Action on the merits but before Final Rejection and/or Notice of Allowance.

Attached are copies of two Japanese Unexamined Patent Publications: No. 9-331004 and No. 2000-195900 and their English-language translations. The Japanese publications were cited in a Japanese Office Action dated September 13, 2005 for the corresponding Japanese Patent Application No. 11-029842. Any relevance of the Japanese publications can be gleaned from the English translations. The publications are listed on the attached Form PTO-1449. Consideration of the documents is respectfully requested.

It is hereby certified that each item of information contained in this Information Disclosure Statement was first cited in a communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this Information Disclosure Statement.

Respectfully submitted,



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October 4, 2005

Date

SMR/pjl

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<b>FORM PTO-1449</b> <b>INFORMATION DISCLOSURE STATEMENT</b> 		Atty Docket	Application No.				
		AI 257D1	10/797,018				
		Applicant	<b>Junichi HIKITA et al.</b>				
		Filing Date <b>March 11, 2004</b>	Group Unit <b>2811</b>				
<b>U.S. PATENT DOCUMENTS</b>							
Examiner Initial		Document Number	Date	Name	Class	Sub-Class	Filing Date
	AA						
	AB						
	AG						
	AD						
	AE						
	AF						
	AG						
	AH						
<b>FOREIGN PATENT DOCUMENTS</b>							
		Document Number	Date	Country	Class	Sub-Class	Trans-lation
	AI	JP09-331004	12/22/97	Japan			Yes
	AJ	JP2000-195900	07/14/00	Japan			Yes
	AK						
	AL						
	AM						
	AN						
	AO						
<b>OTHER (Including Author, Title, Date, Pertinent Pages, etc.)</b>							
	AP						
	AQ						
	AR						
Examiner					Date Considered		
EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.							